

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI, et al.

Title: SILICON CARBIDE PRODUCT, METHOD
FOR PRODUCING THE SAME, AND
METHOD FOR CLEANING SILICON
CARBIDE PRODUCT

Appl. No.: 10/566,099

Filing Date: 01/27/2006

Examiner: Unassigned

Art Unit: Unassigned

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.56

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56.

A copy of each non-U.S. patent document and each non-patent document is being submitted to comply with the provisions of 37 CFR §1.97 and §1.98.

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* art reference against the claims of the present application.

TIMING OF THE DISCLOSURE

The listed documents are being submitted in compliance with 37 CFR §1.97(b), within three (3) months of the date of entry of the national stage as set forth in 37 CFR §1.491.

RELEVANCE OF EACH DOCUMENT

The documents cited in the Information Disclosure Statement filed on January 27, 2006, were listed in the International Search Report. These documents are included on the attached SB/08, and copies of the documents are also attached. Additionally, the references discussed on page 1 are also cited and attached.

English abstracts are provided for each foreign-language reference. The absence of a full English translation does not relieve the PTO from its duty to consider the submitted foreign language documents (37 CFR §1.98 and MPEP §609).

Applicants respectfully request that each listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

Although Applicant believes that no fee is required for this Request, the Commissioner is hereby authorized to charge any additional fees which may be required for this Request to Deposit Account No. 19-0741.

Respectfully submitted,

Date March 3, 2006

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Substitute for form 1449B/PTO		<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			
Date Submitted: March 3, 2006			
(use as many sheets as necessary)			
Sheet	1	of	1
		Attorney Docket Number	039262-0147
		Application Number	Unassigned
		Filing Date	January 27, 2006
		First Named Inventor	Tadahiro OHMI
		Group Art Unit	Unassigned
		Examiner Name	Unassigned

U.S. PATENT DOCUMENTS

U.S. PATENT APPLICATION DOCUMENTS

U.S. PATENT APPLICATION DOCUMENTS					
Examiner initials*	Cite No. ¹	U.S. Patent Application Document		Name of Patentee or Applicant of Cited Document	Filing Date of Cited Document MM-DD-YYYY
		Serial Number	Kind Code ² (if known)		

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴				
/N.B./	B1	JP	11-008216	A Toshiba Ceramics Co.	01-12-1999		A
/N.B./	B2	JP	2003-86792	A Nat Inst of Adv Ind & Tech	03-20-2003		A
/N.B./	B3	JP	6-128036	A Shinetsu Chemical Co.	05-10-1994		A

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ³
/N.B./	B4	De VASCONCELOS et al., "Potential of High-purity Polycrystalline Silicon Carbide for Thermistor Applications," Japanese Journal of Applied Physics, Part 1, September 15, 1998, Vol. 37:9A, pp. 5078-5079.	
/N.B./	B5	CHINONE et al., "Applications of High Purity SiC Prepared by Chemical Vapor Deposition," Amorphous and Crystalline Silicon Carbide II, Springer Proceedings in Physics, Vol. 43, 1989, pp. 198-206.	

Examiner Signature	/Naomi Birbach/	Date Considered	02/11/2009
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the issue of the Emperor must precede the serial number of the patent document.

⁵Kind of language by the appropriate symbol as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Burden Hour Statement. This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. **DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:** Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.